## IN THE CLAIMS:

- 1. (amended) An interferometric strain gage sensor which comprises:
- a support;
- a first layer of polymeric material having a first refractive index;
- a second layer of polymeric material having a second refractive index which second
- 5 refractive index is distinct from the first refractive index, the sensor having a gage factor of at
- 6 least 100 and light energy communicates with the sensor, when a strain is applied to the
- sensor, the light energy is partly absorbed and the change in light energy correlates to the
- 8 strain applied, the sensor being passive and one of said layers being filled with particulate.
- 1 2. (original) The sensor of claim 1 which comprises:
- a plurality of alternating first and second layers.
- 1 3. (original) The sensor of claim 2 wherein the first layer has a refractive index of
- 2 approximately 1.6 to 1.7 and is selected from the group consisting of polyimides and
- 3 polycarbonates.

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- 4. (original) The sensor of claim 3 wherein the first layer is polyimide.
- 5. (original) The sensor of claim 2 wherein the second layer has a refractive index
- of about 1.4 and is selected from the group consisting of polysiloxane, polyethylene.
- 3 polypropylene, Teflon®, polyvinylidene fluoride and polyester.

6. (original) The sensor of claim 5 wherein the second layer is polysiloxane. 1 7. (original) The sensor of claims 4 or 6 wherein the thicknesses of the layers are 1 between about 1 to 20 microns. 2 8. (cancelled) The sensor of claim 1 which comprises: 1 2 means for contacting the sensor with light energy; and means for measuring changes in the light energy. 3 9. (cancelled) The sensor of claim 1 wherein the sensor is a passive sensor and 1 2 one of said layers is filled with particulate. 10. (amended) The sensor of claim 9 1 wherein there are multiple first and second 1 layers in alternating relationship, the first layer selected from the group consisting of 2 3 polyimides and polycarbonates, the second layer selected from the group consisting of polysiloxane, polyethylene, polypropylene, Teflon®, polyvinylidene fluoride and polyester. 4 11. 1 (original) The sensor of claim 10 wherein the first layer is polyimide and the 2 second layer is polysiloxane filled with aluminum oxide particulate. 12. 1 (amended) The sensor of claim 9 1 which comprises: 2 means for contacting the sensor with light energy; and

means for measuring changes in the light energy.

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- 1 13. (amended) An interferometric strain gage sensor which comprises:
- a first layer of polymeric material having a first refractive index;
- a second layer of polymeric material having a second refractive index which second
- 4 refractive index is distinct from the first refractive index, the sensor having a gage factor of at
- 5 least 100 and light energy communicates with the sensor, when a strain is applied to the
- 6 sensor, the light energy is partly absorbed and the change in light energy correlates to the
- 7 strain applied, the sensor being an active strain gage and further comprising The sensor of
- 8 claim 1 wherein the sensor is an active strain gage and comprises a tube-like support for the
- 9 first and second layers.
- 1 14. The sensor of claim 13 wherein the first layer has a refractive index of
- 2 approximately 1.6 to 1.7 and is selected from the group consisting of polyimides and
- 3 polycarbonates, and wherein the second layer has a refractive index of about 1.4 and is
- 4 selected from the group consisting of polysiloxane, polyethylene, polypropylene, Teflon®,
- 5 polyvinylidene fluoride and polyester.
- 15. The sensor of claim 14 wherein the which further comprises a third layer
- 2 comprised of outer most layer is coated with aluminum.
- 1 16. The sensor of claim 15 which comprises:
- means for contacting the sensor with light energy; and
- means for measuring changes in the light energy.